Structured illumination for 3D Measurements

- Uniformly sharp grid in whole projection field due to 30° Scheimpflug projection
- Incoherent light source: high power LED, suitable for high frequency external modulation for grid projection without speckle and diffraction fringes
- Projection field 5 mm x 10 mm
- Height measurement range (projection limited) ± 0.5 mm
- Height resolution <4 μm with standard matrix cameras

Multi-line light-sectioning is a technique to measure small height differences in structured objects by using a grid projected onto the object surface at a low angle. A matrix camera perpendicular to the object is used to record the image of the projected grid lines. A structured object distorts or displaces the grid image and this is recorded by the camera for evaluation of the line displacement and calculation of the object height, contour or profile.

The grid lines are generally projected onto the object at an angle of 30° to the object plane (60° to the optical axis of the imaging camera) using the Scheimpflug principle to generate evenly illuminated grid lines with a rectangular intensity profile.

The use of a broadband and incoherent light source is advantageous because the resulting structured illumination of the Precision Grid Projector is totally free of the inherent speckling of structured illumination laser sources.

### Table 1

<table>
<thead>
<tr>
<th>Sensor</th>
<th>1/3''</th>
<th>1/2''</th>
<th>2/3''</th>
<th>CMOS 1024</th>
</tr>
</thead>
<tbody>
<tr>
<td>Pixel number (horiz.)</td>
<td>756</td>
<td>756</td>
<td>756</td>
<td>1024</td>
</tr>
<tr>
<td>Pixel size /μm</td>
<td>6.3</td>
<td>8.5</td>
<td>11.6</td>
<td>10</td>
</tr>
<tr>
<td>Image field width /mm</td>
<td>4.8</td>
<td>6.4</td>
<td>8.8</td>
<td>10.2</td>
</tr>
<tr>
<td>Height resolution /μm</td>
<td>3.7</td>
<td>4.9</td>
<td>6.7</td>
<td>5.8</td>
</tr>
<tr>
<td>Meas. range continuous/mm</td>
<td>± 0.5</td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Meas. range non-cont. /mm</td>
<td>0.58</td>
<td></td>
<td></td>
<td></td>
</tr>
</tbody>
</table>

### Table 2

<table>
<thead>
<tr>
<th>f-Number</th>
<th>Depth of focus /mm</th>
</tr>
</thead>
<tbody>
<tr>
<td>2.8</td>
<td>0.07</td>
</tr>
<tr>
<td>4</td>
<td>0.10</td>
</tr>
<tr>
<td>4.5</td>
<td>0.11</td>
</tr>
<tr>
<td>5.6</td>
<td>0.14</td>
</tr>
</tbody>
</table>

### Dimensions

**Precision Grid Projector SK5732**

- Projection field: 5 x 10 mm
- Projection angle: α = 30°
- Structure: 15 strips
- Light source: LED
- Lifetime: 30,000 hours
- Wavelength: 627 ± 30 nm
- Weight: 700 g
- Dimensions: 110 x 227 x 52 mm
- Free working dist.: 38 mm
- Power supply: 5V / 1.4A

### Height Resolution

The height resolution of this measurement technique is determined by the projection angle of the grid and by the spatial resolution of the matrix camera.

\[ \Delta h = \beta \Delta x \tan (\alpha) \]

where

- \( \Delta h \): Height difference corresponding to a single pixel width of the sensor
- \( \beta \): Magnification, \( \beta = \text{Object width} / \text{Sensor width} \)
- \( \Delta x \): Pixel size in direction x
- \( \alpha \): Projection angle of the grid in respect of the object plane (30°).

**Example:**

1/3'' CCD camera with 756 x 581 pixels, sensor size 4.8 mm x 3.6 mm,

pixel size \( \Delta x = 6.3 \mu m \), magnification \( \beta = 1 \), region recorded on object of 4.8 mm x 3.6 mm,

\[ \Delta h = 1 \times 6.3 \mu m \times \tan(30°) = 3.7 \mu m \]

The displacement of a grid line by 1 pixel = a height difference of 3.7 μm.

Due to the speckle free projected grid lines, subpixel algorithms can be used to further increase the measurement resolution. The resolution achieved in practice also depends on properties of the object surface. A rough surface texture, for example, complicates the edge detection and thus also decreases the measurement resolution.

### Measurement Range

The measurement range is different for continuous and non-continuous height changes.

Non-continuous height changes (steps or leaps) lead to ambiguous recordings if the line displacement is equal to or greater than the distance between two grid lines. This limit corresponds to the height difference

\[ \Delta h = \Delta L \tan (\alpha) \]

where

- \( \Delta h \): Height difference measurable from the grid line spacing interval
- \( \Delta L \): Grid line spacing interval
- \( \alpha \): Projection angle of the grid, with respect to the object plane (30°).

**Example:** A grid line interval of 1 mm = a height discrimination distance of 0.58 mm.

Gradual height changes lead to unambiguous and traceable grid displacements. The depth of focus of the grid projection thus limits the height measurement range to approximate ±0.5 mm.